



PATENT  
81788.0025

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Seiichi Mori

Serial No: 09/451,619

Filed: November 30, 1999

For: NON-VOLATILE  
SEMICONDUCTOR MEMORY  
AND MANUFACTURING  
METHOD THEREOF

Art Unit: 2814

Examiner: Weiss, Howard

I hereby certify that this correspondence  
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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450, on

February 6, 2004

Date of Deposit

Anthony J. Orler, Reg. No. 41,232

Signature

February 6, 2004

Date

PETITION FOR EXTENSION OF TIME

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the Commissioner for a three-month extension of time extending to February 6, 2004, the period for response to the Office Action dated August 6, 2003. Please charge the fee of \$950.00 for this extension to Deposit Account No. 50-1314. The responsive paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account No. 50-1314. A copy of this petition is enclosed.

Respectfully submitted,

HOGAN & HARTSON LLP.

By: 

Anthony J. Orler

Registration No. 41,232

Attorney for Applicant(s)

Date: February 6, 2004

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